FORM PTO 1449 (modified)					ATTY DOCKET NO. 03500.017473 APPLIC			ICATION NO 10/521,242	
U.S. DEPARTIVENT OF COMMERCE PATENT AND TRADEWARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				APPLICANT Miki Ogawa					
				FILING	DATE January	gROUP 1792			
				U.S. PAT	TENT DOCUMENTS				
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		English language to Silica Thin Film"; Z	ranslation eolite, Vol	of Miy	ata, "Control o o. 2 (Jun. 10, 26	f Orientati 002)	ion of Fine	Pores in Mesoporous	
		English language translation of Miyata, "Preparation and Characterization of Mesoporous Silica Films with Uniaxially Aligned Channel Structure"; Ceramics Japan, Vol. 36(12) (Dec. 1, 2001)							
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"EXAMINER" Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet	1	of	1